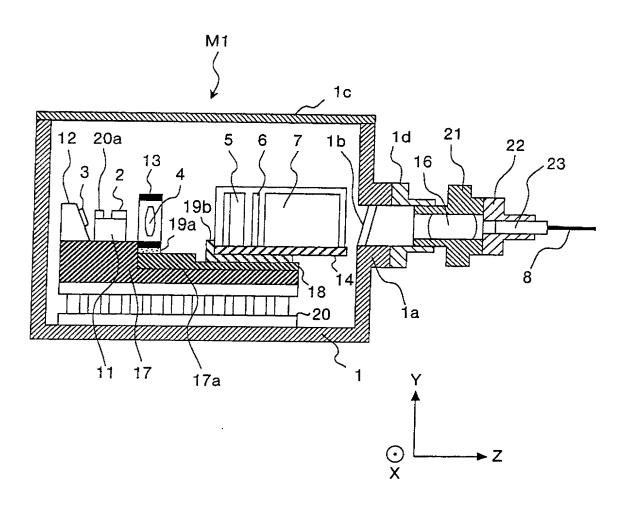
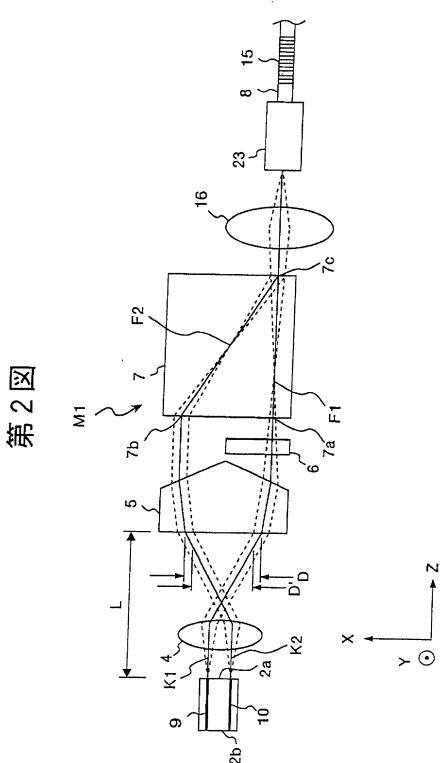
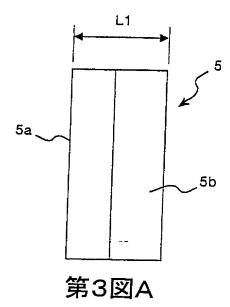
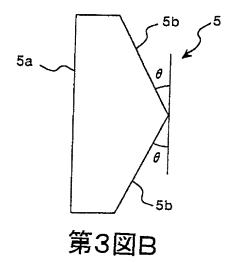
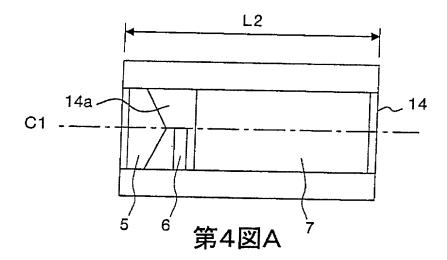
## 第1図

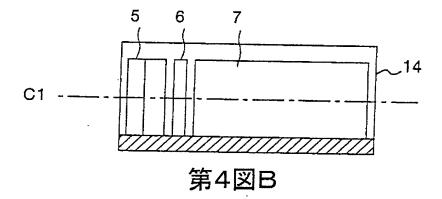


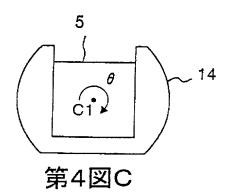




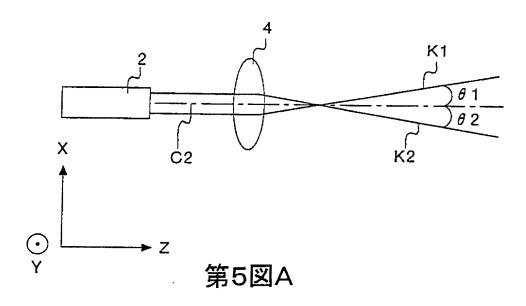


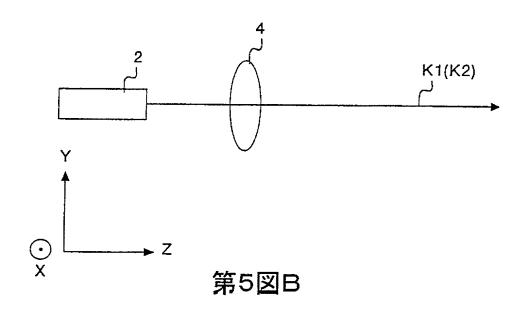


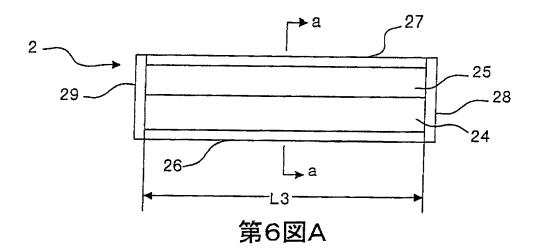


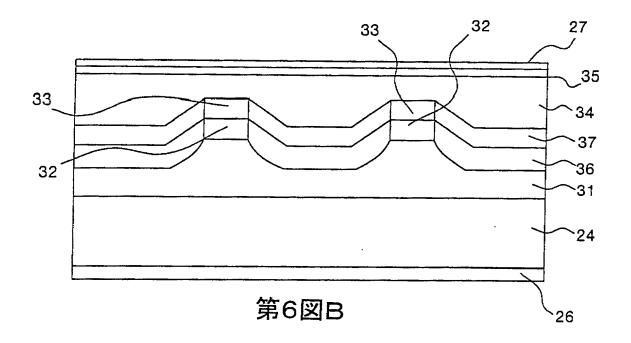


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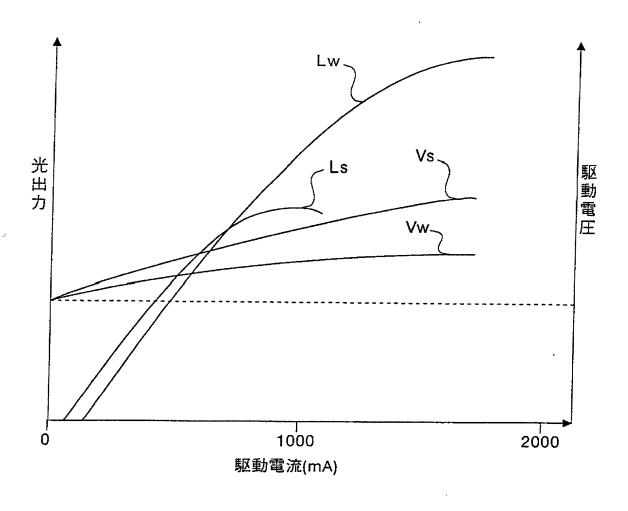






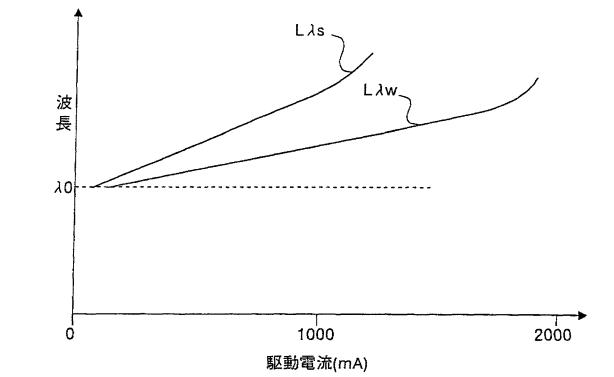


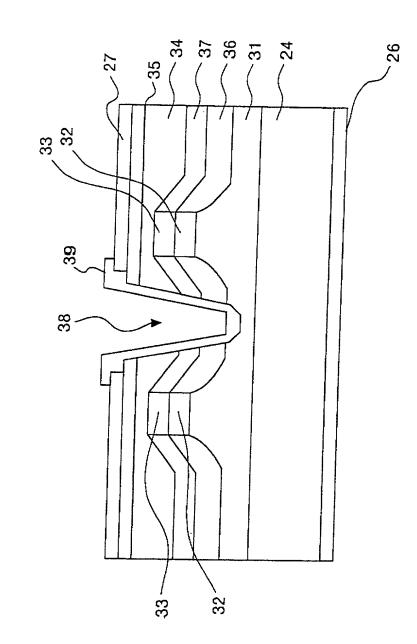
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第8図

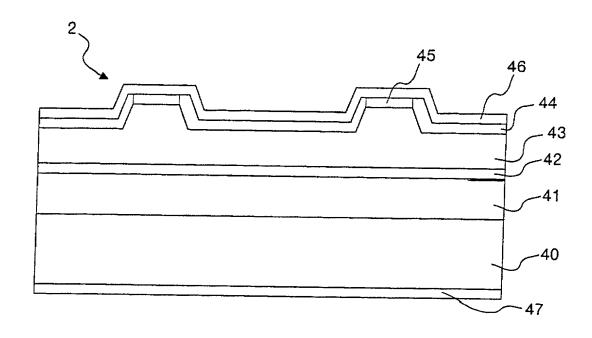






鄉9図

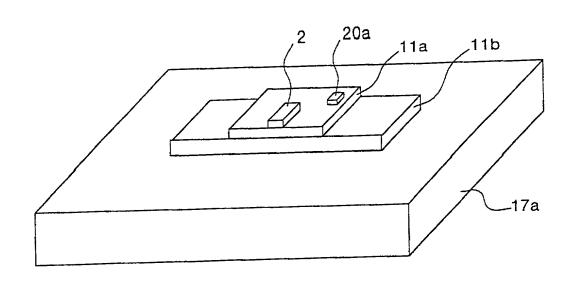
# 第10図



OBLON, SPIVAK, ET AL DOCKET #: 217494US8 INV: Sadayoshi KANEMARU, et al. SHEET \_11\_ OF\_18\_

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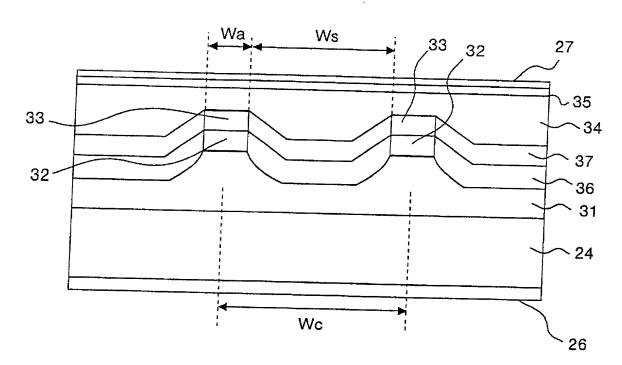
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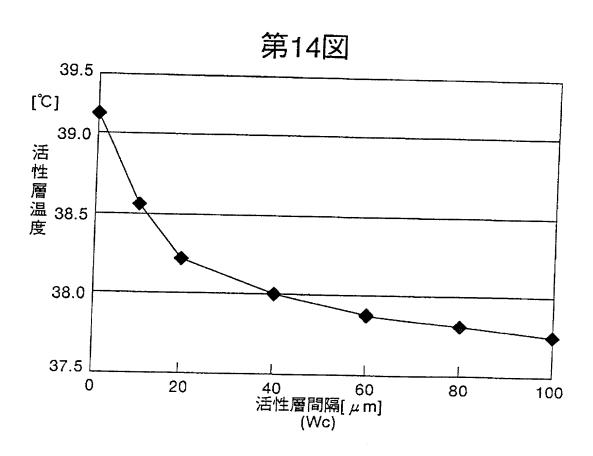


第12図

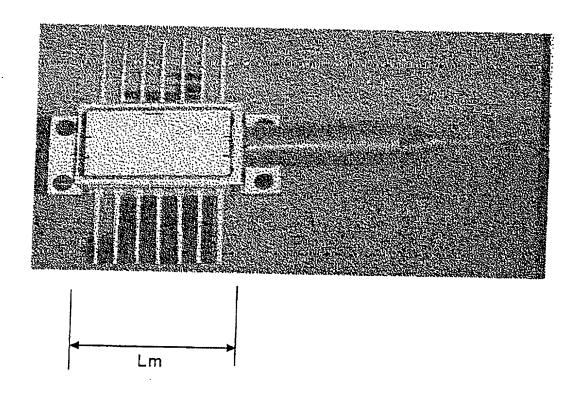
		A	В
上部ヒートシンク		CVDダイヤモンド	AIN
下部ヒートシンク		AIN	AIN
発熱量[W]	左活性層	2.5	2.5
	右活性層	2.5	2.5
温度[℃]	左活性層	37.96	49.53
	右活性層	37.96	49.53
	マウント上部	26.76	26.77

#### 第13図

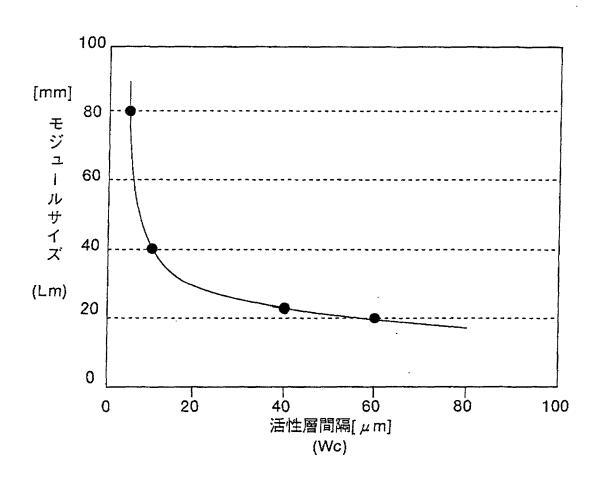




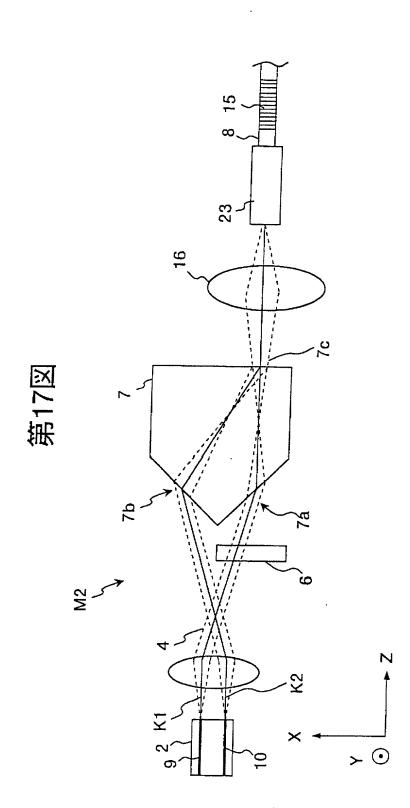
# 第15図

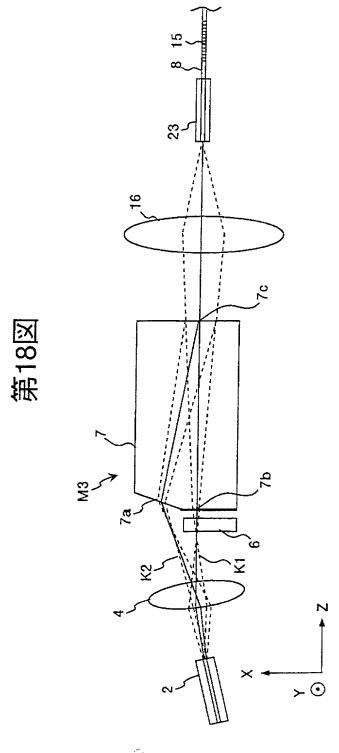


#### 第16図

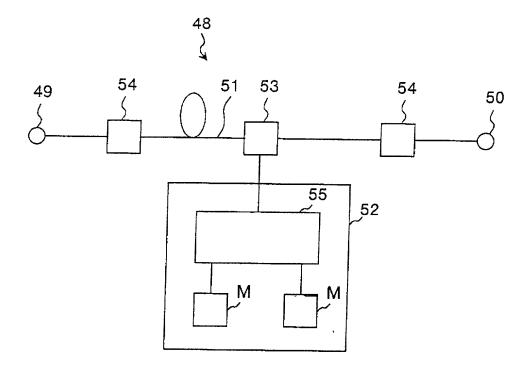


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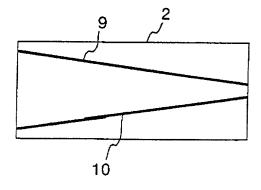




# 第19図



## 第20図





## 第21図

